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**RESPONSE UNDER 37 C.F.R. § 1.116**  
**-- EXPEDITED PROCEDURE --**  
**EXAMINING GROUP 2800**

Our Docket No: 42P13230D

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: )

Shafquat Ahmed et al. )

Examiner: Booth, Richard

Serial No: 10/619,961 )

Art Unit: 2812

Filed: July 15, 2003 )

For: Method of Forming Transistor Having )  
Insulating Spacers On Gate Sidewalls )

**RESPONSE TO FINAL OFFICE ACTION**

Mail Stop: AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed August 31, 2005, the Applicants respectfully request that the Examiner enter the following amendments and consider the following remarks.

**FIRST CLASS CERTIFICATE OF MAILING**

I hereby certify that I am causing the above-referenced correspondence to be deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and that this paper or fee has been addressed to the Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

November 30, 2005

Date of Deposit

Krista Mathieson

Name of Person Mailing Correspondence

Signature

Date

Krista Mathieson November 30, 2005